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APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/684,409	10/15/2003		Dae-Won Kim	253/039	4381
7590 08/23/2005				EXAMINER	
LEE & STER	BA, P.C	.	PHAM, MINH CHAU THI		
Suite 2000 1101 Wilson Boulevard				ART UNIT	PAPER NUMBER
Arlington, VA 22209				1724	

DATE MAILED: 08/23/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/684,409	KIM ET AL.				
Office Action Summary	Examiner	Art Unit				
	Minh-Chau T. Pham	1724				
The MAILING DATE of this commun	nication appears on the cover sheet wit					
A SHORTENED STATUTORY PERIOD F THE MAILING DATE OF THIS COMMUN - Extensions of time may be available under the provisions after SIX (6) MONTHS from the mailing date of this comr - If the period for reply specified above is less than thirty (3 - If NO period for reply is specified above, the maximum st - Failure to reply within the set or extended period for reply Any reply received by the Office later than three months earned patent term adjustment. See 37 CFR 1.704(b).	ICATION. s of 37 CFR 1.136(a). In no event, however, may a re munication. 30) days, a reply within the statutory minimum of thirty tatutory period will apply and will expire SIX (6) MONT will, by statute, cause the application to become ABA	eply be timely filed (30) days will be considered timely. FHS from the mailing date of this communication. ANDONED (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) file	ed on <u>22 <i>April 2005</i>.</u>					
2a) This action is FINAL . 2b) This action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practi	ice under <i>Ex parte Quayle</i> , 1935 C.D.	. 11, 453 O.G. 213.				
Disposition of Claims						
4)⊠ Claim(s) <u>1-20</u> is/are pending in the	application.					
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.	•					
6)⊠ Claim(s) <u>1-20</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restrict	ction and/or election requirement.					
Application Papers						
9)☐ The specification is objected to by th	e Examiner.	·				
10)☐ The drawing(s) filed on is/are		by the Examiner.				
	ction to the drawing(s) be held in abeyand					
	g the correction is required if the drawing(
11)☐ The oath or declaration is objected to	o by the Examiner. Note the attached	Office Action or form PTO-152.				
Priority under 35 U.S.C. § 119						
2. Certified copies of the priority3. Copies of the certified copies	documents have been received. documents have been received in Apof the priority documents have been and Bureau (PCT Rule 17.2(a)).	oplication No received in this National Stage				
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (P3) Information Disclosure Statement(s) (PTO-1449 or Paper No(s)/Mail Date J.S. Patent and Trademark Office PTOL-326 (Rev. 1-04)	PTO-948) Paper No(s)	ummary (PTO-413) /Mail Date formal Patent Application (PTO-152)				

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Claim Rejections - 35 USC § 103

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claims 1, 2, 15 and 17-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over The Japanese reference (JP 2164412), in view of Lurie (2,877,863).

The Japanese reference discloses a filter protection apparatus comprising a frame (1) having a shape of a filter securing part for securing an air filter (50), an attaching part for attaching the frame to the filter securing part (2a, 2b, 48), and a protection part (52, 54) which is coupled on the inner surface of the frame to occupy the inner space with a plurality of minute holes through which air passes for protecting the filter (50) from damage. The Japanese reference further discloses the protection part formed on Aluminum (see Abstract), and the filter protection net (52, 54) having a plurality of holes through which filtered air passes (see Fig. 3). Claims 1, 2, 15 and 17-20 differ from the disclosure of the Japanese reference in that the protection part being spaced a predetermined distance away from the filter. Lurie discloses protection part (18) being spaced a predetermined distance away from the filter (14) (see details of Fig. 5, col. 2, lines 4-19). It would have been obvious to a person having ordinary skill in the art at the time the invention was made to provide a protection part spaced away from the filter medium as taught by Lurie in the filter apparatus of the Japanese reference in order to effectively protect the filter from damage.

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Claims 3-14 and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over The Japanese reference (JP 2164412), in view of Lurie (2,877,863), as applied supra, and further in view of Northcut (6,554,880 B1).

Claims 3-14 and 16 call for a moving member disposed on the frame and the attaching part is coupled to the moving member to cause the attaching part to move together with the moving member. Northcut discloses a moving member (50, 10) mounted on the frame in engagement with the elongated channels (2) (see details of Fig. 3 and col. 4, lines 1-12), and persons of ordinary skill in the art will understand that the relative size and number of moving members can be any of a wide selection, and the size and position of other components may vary depending on the particular application and range of used desired (col. 4, lines 52-58). It would have been obvious to a person having ordinary skill in the art at the time the invention was made to provide a moving member as taught by Northcut in the filter apparatus of the Japanese reference and Lurie in order to necessitate more frequent rearrangement of the filter cells to achieve optimal filtration while maintaining easy to install and replace a filter.

Response to Amendment

Applicant's arguments filed on April 22, 2005 have been fully considered but they are not persuasive.

Applicant argue that none of the cited prior arts discloses the limitation "the protection part being spaced a predetermined distance away from the filter to protect the filter from damage" as amended. The Examiner maintains the Japanese reference as the primary reference and newly introduces Lurie as the secondary reference in combination with

the primary Japanese reference in the 103 rejections to show the protection part (18) being spaced a predetermined distance away from the filter (14) (see details of Fig. 5, col. 2, lines 4-19), as claimed. It would have been obvious to a person having ordinary skill in the art at the time the invention was made to provide a protection part spaced away from the filter medium as taught by Lurie in the filter apparatus of the Japanese reference in order to effectively protect the filter from damage.

Applicant's arguments with respect to claims 1-20 have been thoroughly considered but are most in view of the new ground(s) of rejection, as discussed above.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Minh-Chau T. Pham whose telephone number is (571) 272-1163. The examiner can normally be reached on Mon/Tues/Thur/Fri 7:00 am - 5:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Duane Smith can be reached on (571) 272-1166. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Minh-Chau Pham Patent Examiner

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August 19, 2005